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PATENT #3/109  
790001-2004 OKING  
9/13/01

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Hiroyuki Yano et al.  
U.S. Serial No. : 09/870,085  
Filing Date : May 30, 2001  
For : **MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE**  
Group Art Unit : Not Known Yet

745 Fifth Avenue  
New York, New York 10151

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231, on July 26, 2001.

Grace L. Pan, Reg. No. 39,440  
Name of Applicant, Assignee or Registered Representative

  
Signature

July 26, 2001  
Date of Signature

WOC1-1001-0002-31  
100-1001-0002-31

**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

The Examiner's attention is respectfully invited to review the following enclosed and listed documents which are also listed on the accompanying Form PTO-1449, enclosed in duplicate.

**UNITED STATES PATENTS**

1. U.S. Patent No. 5,426,073, Issued: June 20, 1995 to Imaoka et al., and
2. U.S. Patent No. 6,016,265, Issued: January 18, 2000 to Yoshida et al.

**FOREIGN PATENTS**

1. Japanese Patent No. 2-100319, Published: April 12, 1990 to Imaoka et al.

Pursuant to Rule 37 C.F.R. §1.97(b)(3), an Information Disclosure Statement shall be considered by the Patent Office filed before the mailing date of a first Office Action on the merits.

This Information Disclosure Statement is not a representation that the documents cited herein are considered most pertinent, or that a search has been undertaken, or that any of the cited documents are indeed prior art. The Examiner is invited to undertake an independent search. Applicants assert that the claimed invention is patentable over these documents.

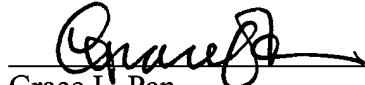
Applicants respectfully request that the Examiner consider and make of record the documents cited herein and that a copy of Form PTO-1449, appropriately initialed by the Examiner, be returned to Applicants' attorney.

It is believed no fee is due, however, the Examiner is authorized to charge any deficit or credit any overpayment to Deposit Account No. 50-0320.

Respectfully submitted,

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